

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Jean-Louis OUVRIER-BUFFET et al.

Application No.: New U.S. Patent Application

Filed: September 5, 2006

Docket No.: 129090

For: METHOD FOR PRODUCTION OF A DEVICE FOR THERMAL DETECTION OF  
RADIATION COMPRISING AN ACTIVE MICROBOLOMETER AND A PASSIVE  
MICROBOLOMETER

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Claims** as reflected in the listing of claims;

**Remarks.**